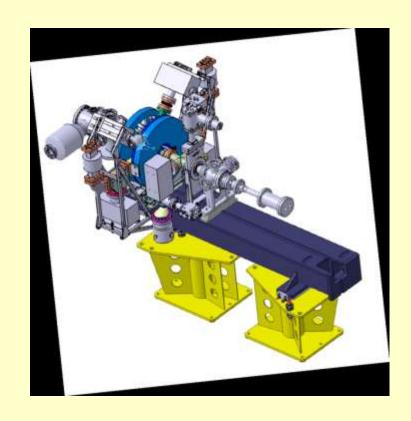


High average current photo injector (PHIN) for the CLIC Test Facility at CERN



- CLIC and CTF3 motivation
- Photo injectors, PHIN
- Emittance measurements
- Long pulse operation, time resolved measurements
- Cathode studies
- Stability
- Phase coding
- Conclusion and outlook





PHIN team



PHIN team and collaboration,
Joint venture within the European CARE program of:

LAL, rf-gun RAL, laser INFN, laser and phase coding CERN, laser, cathodes, integration, commissioning

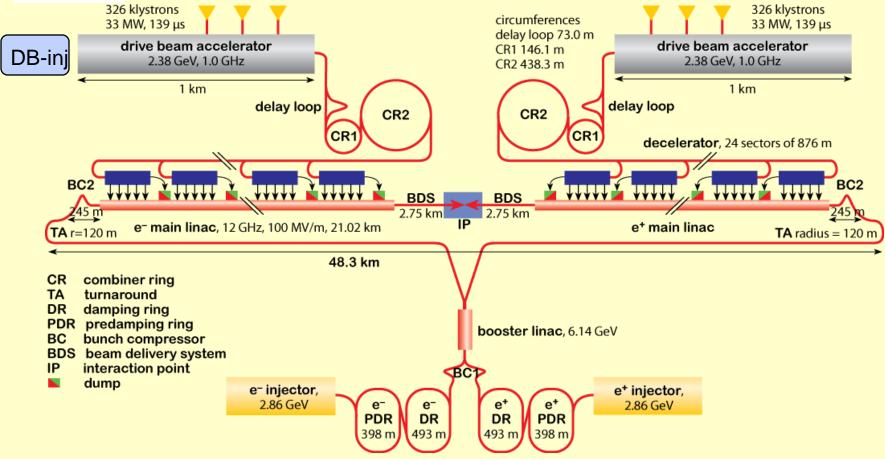
CERN people:

A. Andersson, B. Bolzon, E. Bravin, M. Csatari, E. Chevallay, S. Doebert, A. Drodzy, D. Egger, V. Fedosseev, C. Hessler, T. Lefevre, R. Losito, O. Mete, M. Olvegaard, M. Petrarca, A. Rabiller



CLIC-layout





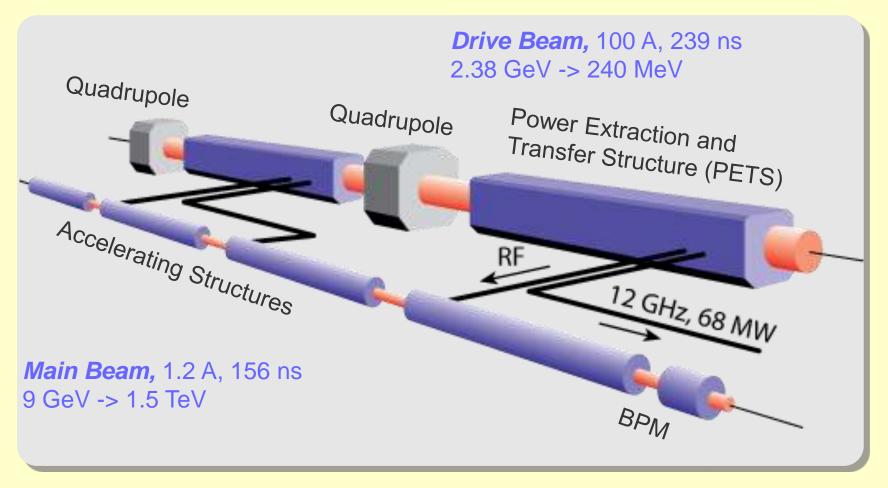
Compact Linear Collider for 3 TeV c.m., normal conducting, highfrequency, high-gradient, high efficiency, two beam acceleration, high-current drive beam



Two Beam acceleration



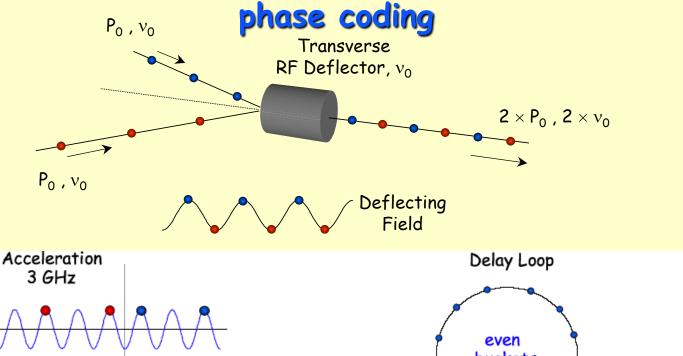
Transformer principle: high-current low-energy drive beam to low-current high energy main beam

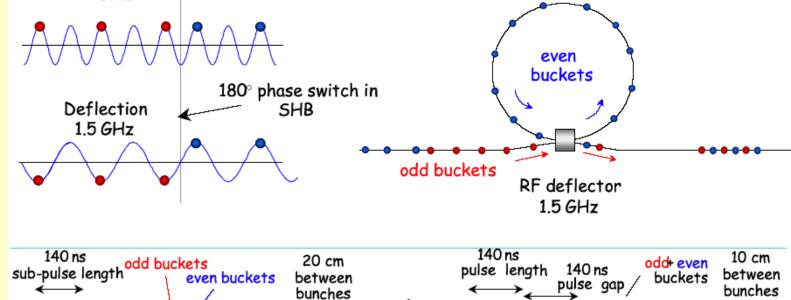




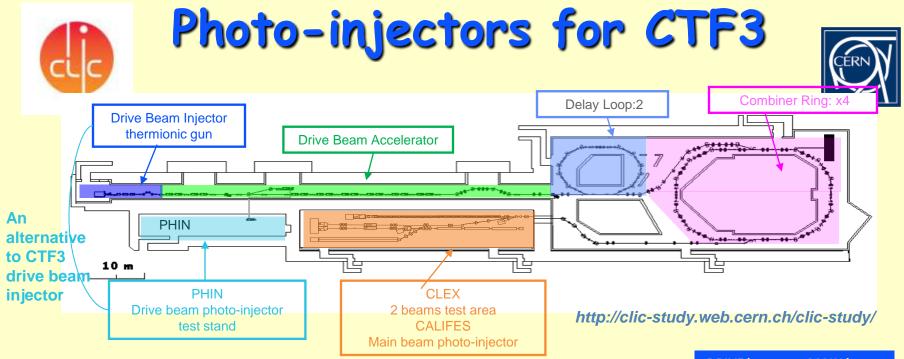
Bunch combination in CTF3

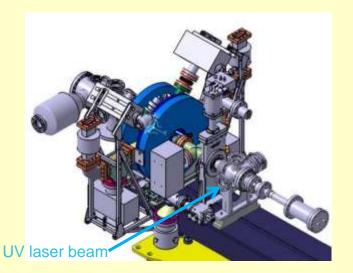






[[[]]]





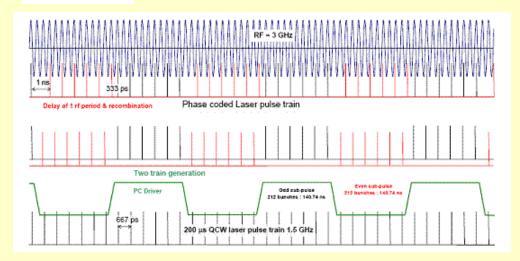
	DRIVE beam	MAIN beam
	PHIN	CALIFES
charge/bunch (nC)	2.3	0.6
Number of subtrains	8	NA
Number of pulses in subtrain	212	NA
gate (ns)	1272	20-150
bunch spacing(ns)	0.666	0.666
bunch length (ps)	10	10
Rf reprate (GHz)	1.5	1.5
number of bunches	1802	32
machine reprate (Hz)	5	5
margine for the laser	1.5	1.5
charge stability	<0.25%	<3%
QE(%) of Cs2Te cathode	3	0.3
	Number of subtrains Number of pulses in subtrain gate (ns) bunch spacing(ns) bunch length (ps) Rf reprate (GHz) number of bunches machine reprate (Hz) margine for the laser charge stability	PHIN

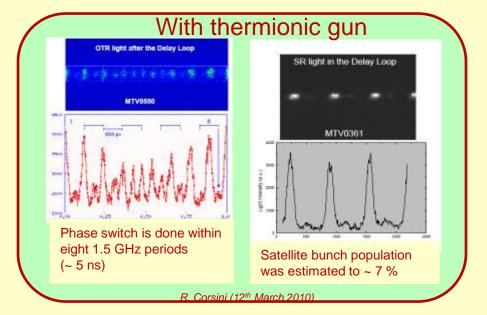
Machine parameters set the requirement for the laser



Time structure requirement







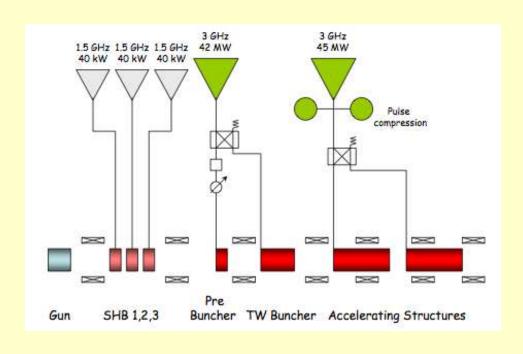
	PHIN
Micropulse repetition rate	1.5GHz
Macropulse repetition rate	1-5 Hz
Number of pulses	1900
Gate length	1254 ns
Number of subtrains	8
Length of subtrains	140.7ns



Thermionic injector



The existing thermionic gun for the CLIC Test Facility 3



time structure is produced by

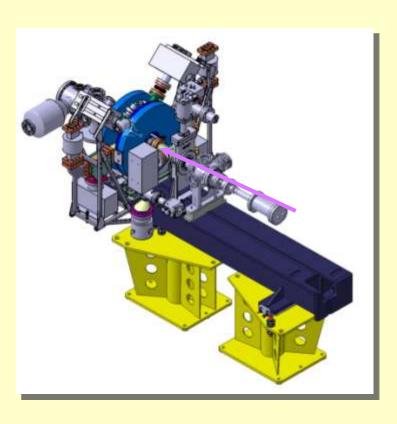
- DC thermionic gun
 - three 1.5 GHz subharmonic bunchers
 - buncher
 - buncher buncher

Drawback: creation of satellites and beam quality degradation



What is a photo injector





- A photoinjector is an electron source that uses laser pulses in order to extract electrons from the surface of a metallic or semiconductor cathode by using the photoemission process.
- ▶ The electron beam resembles the temporal structure of the laser beam therefore it is a compact system without need for an additional bunching system.
- An RF cavity is used for rapid acceleration of the electrons after the emission.
- Solenoid magnets are placed in order to focus the space charge dominated beam and achieve the emittance compensation.



Photo injector option

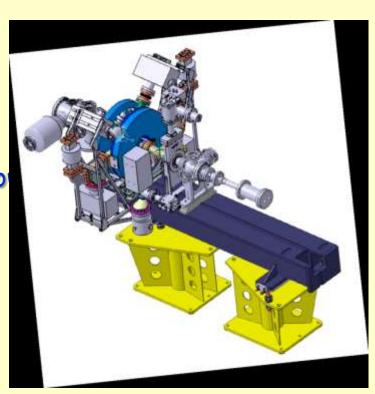


Advantages

- No satellites or tails, phase coding on the laser side
- No or less bunching needed, possibly better emittance
- Flexible time structure

Concerns

- Cathode lifetime
- Challenging laser, peak and average po
- Intensity stability
- Maintenance and operation





PHIN parameters



Parameter	Achieved	
RF		
RF Gradient (MV/m)	85	
RF Frequency (GHz)		
Electron Beam		
Charge per Bunch (nC)	2.33	9.2
Charge per Train (nC)	> 5800	
Train Length (ns)	> 1500	
Bunch Length (ps)	7	
Number of Bunches / Train	1908	2250
Current (A)	3.5	13
Normalized Emittance (mm mrad)	<25	14
Energy Spread (%)	<1	0.7
Energy (MeV)	5.5	5.5
Charge stability, flat top and p. to p. (%)	0.25	0.8

PHIN is special due to the high average charge requirements and the emphasis on stability along the train



Photo injectors from Öznur's thesis



The magnoment is deposed.	2 Your cinquist may not have exough mornior to spen the image, or	Y THE HOSE HIS TIME BOOK CHILDRED AUTOM ANY CHILDRES WITCHES SPAY THE ME HE WERE ATTRIBUTED, AND	minimatic follows the majoration man't spin.			
-					compled fester your cospu	lan, and then



PHIN research objectives



- Comprehensive simulations for the PHIN photo injector beam dynamics,
- Optimization of the working point providing the specifications,
- Full experimental characterization of the PHIN beam for short and long pulse trains,
- Development of a single shot emittance measurement system for space charge dominated beams,
- To measure the beam properties and their **stability** along the bunch train (time-resolved measurements),
- To compare the measurement results with the simulations,
- Eventually, to study the consequences of the findings to constitute a preliminary RF gun design for CLIC-DB injector.



A bit of theory from C. Travier



Maximum gradient

$$E_{0,max} = 8.47 + 1.57\sqrt{f[MHz]}$$

Bunch length

$$\sigma_b[ps] \le \frac{5 \times 10^4}{f[MHz]}$$

Maximum bunch charge, space charge limitations

$$Q_{max}[nC] = \frac{E_{acc}[MV/m]\sigma_x^2}{18}$$

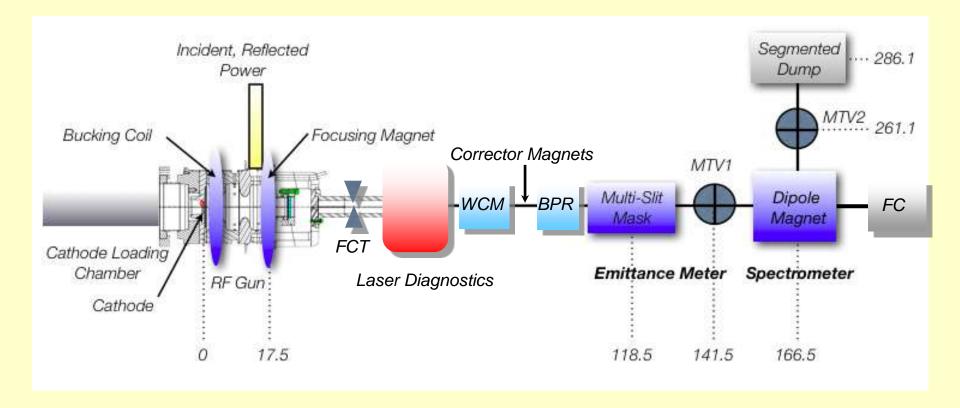
Emission phase, Energy, Energy spread, Emittance
 Depends on rf- phase and focusing, phase < 90 deg (on crest)

$$\epsilon_{n,x,y,tot} = \sqrt{\epsilon_{rf}^2 + \epsilon_{sc}^2 + \epsilon_{th}^2}$$



PHIN Photo injector Layout

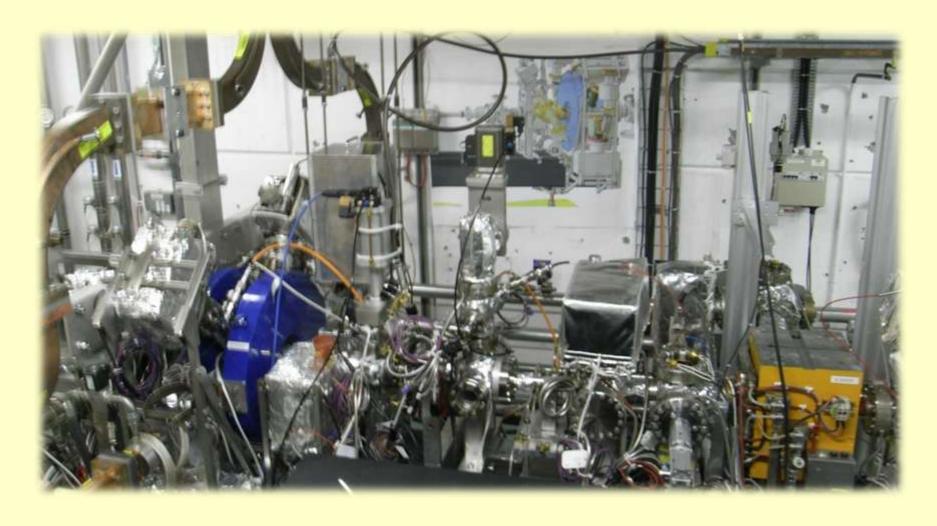






PHIN picture

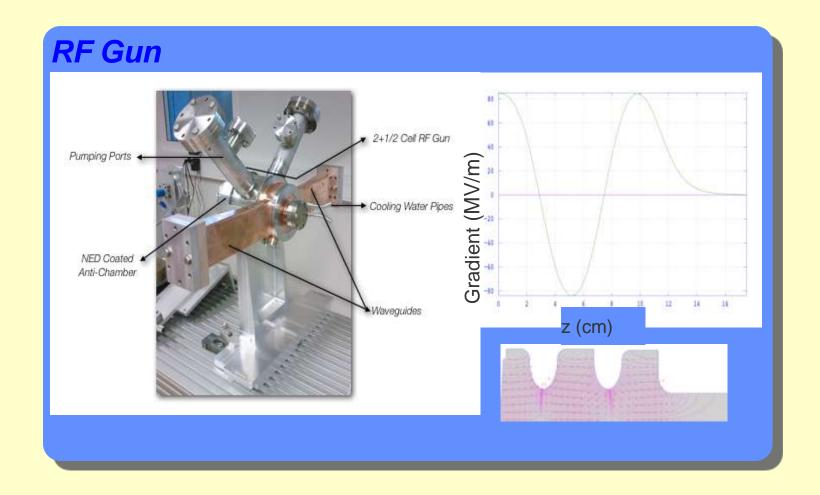






RF-GUN developed by LAL

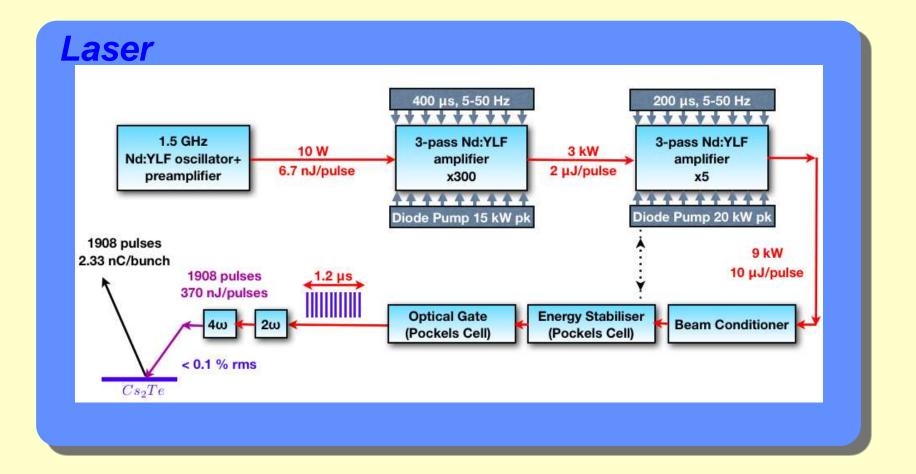






Laser Developed by RAL







Dream Laser

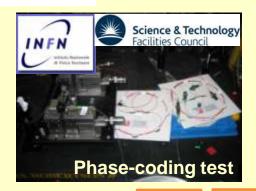




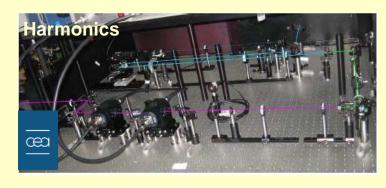


Laser setup









Phasecoding test

10W

amplifie r

3.5kW

2-pass

8.3kW 7.8kW 14.8mJ in 1.2μ

<u>W</u> 2ω

3.6kW 4.67mJ in 1.2µs 4ω 1.25kW

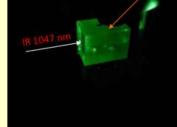
1.5mJ in 1.2µs

HighQ front end

Science & Technology
Facilities Council

AMP1 head assembly





Harmonics test stand



Phin parameters

DRIVE beam

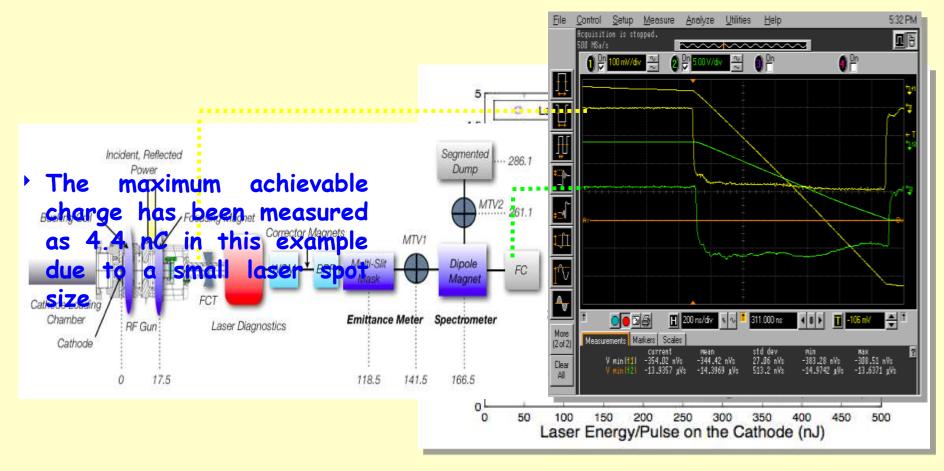


		PHIN	CLIC
	charge/bunch (nC)	2.3	8.4
	train length (ns)	1200	140371
ω.	bunch spacing(ns)	0.666	1.992
Electrons	bunch length (ps)	10	10
ctr	bunch rep rate (GHz)	1.5	0.5
Ele	number of bunches	1802	70467
	machine rep rate (Hz)	5	100
	margine for the laser	1.5	2.9
	charge stability	<0.25%	<0.1%
	Cathode lifetime (h) at QE > 3%	>50	>150
	laser wavelegth (nm)	262	262
>	energy/micropulse on cathode (nJ)	363	1988
	energy/micropulse laserroom (nJ)	544	5765
Laser in UV	energy/macrop. laserroom (uJ)	9.8E+02	4.1E+05
ase	mean power (kW)	0.8	2.9
ĭ	average power at cathode wavelength(W)	0.005	41
	micro/macropulse stability	1.30%	<0.1%
	conversion efficiency	0.1	0.1
<u>~</u>	energy/macropulse in IR (mJ)	9.8	4062.2
Laser in IR	energy/micropulse in IR (uJ)	5.4	57.6
Ser	mean power in IR (kW)	8.2	28.9
La La	average power on second harmonic (W)	0.49	406
	average power in final amplifier (W)	9	608



Charge measurement





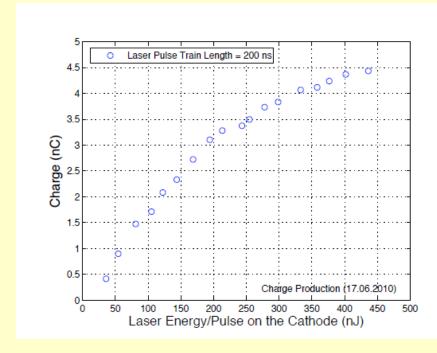
$$Q_{max}[nC] = \frac{E_{acc}[MV/m]\sigma_x^2}{18} = \frac{85[MV/m](1[mm])^2}{18} = 4.7nC$$

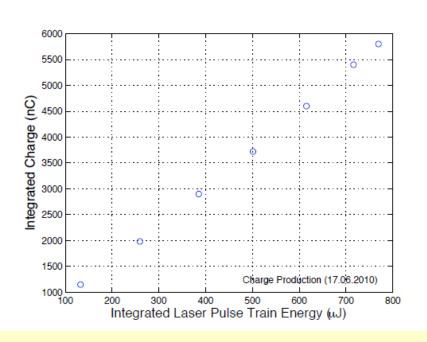


Charge production



Showed in CTF2 already the bunch charge needed (> 10 nC)
Total charge test performed in the cathode lab (> 1 mC)
460 h with 1.5% QE have been shown in excellent vacuum
Combination of those together has not yet been demonstrated
Cathode lifetime under this rough conditions is a big concern

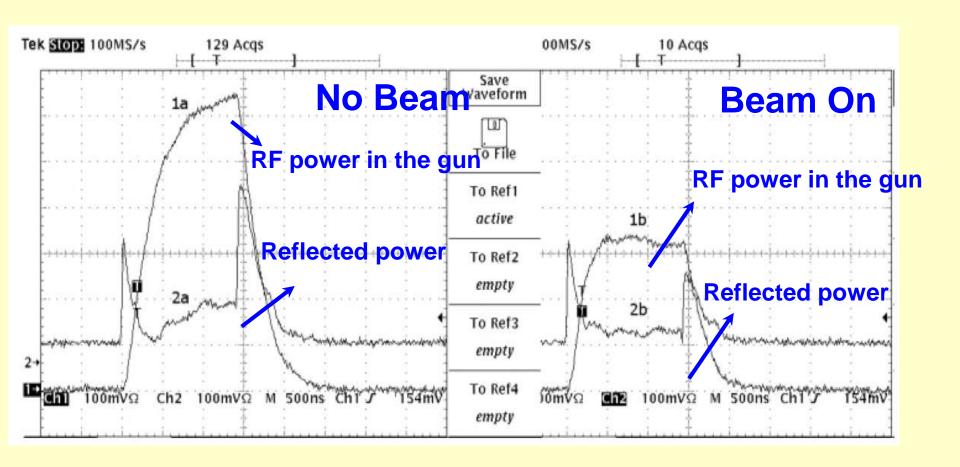






Beam loading compensation

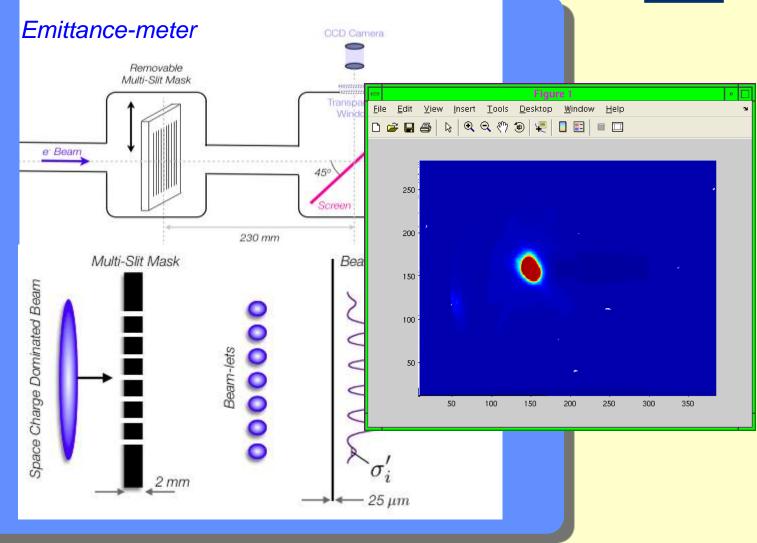






Beam size and Emittance

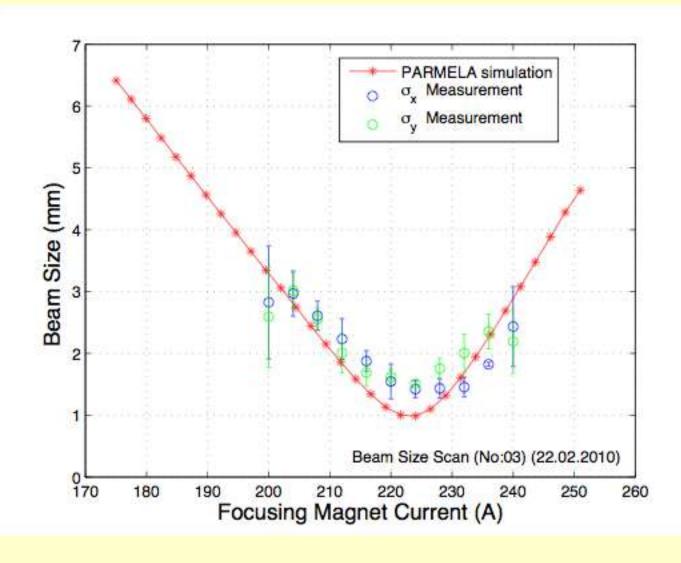






Transverse Diagnostics Solenoid scan

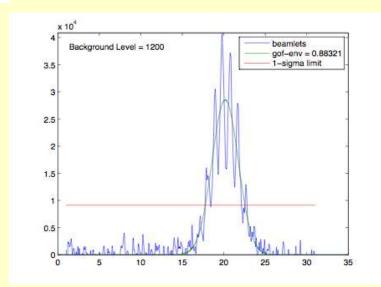


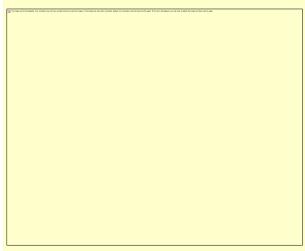


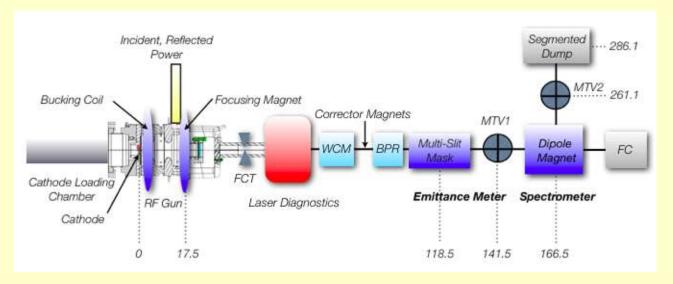


Multi slit emittance measurment









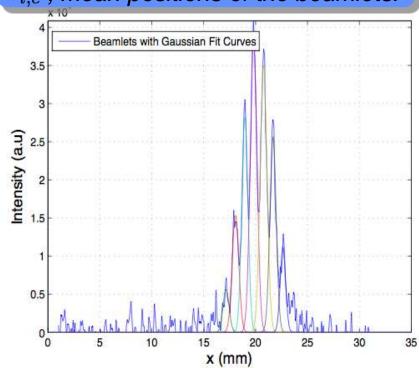


Multi slit emittance



 ρ_i , intensity of individual beamlets.

 $x_{i,c}$, mean positions of the beamlets.



 $x_{i,c}^{\prime}=< x_i-iw>/L$, divergences of the beamlets

 σ'_i , spread on the divergences.

Emittance Calculation

The definition of the transverse geometric emittance.

$$\epsilon_x \equiv \sqrt{\langle x^2 > \langle x'^2 > - \langle xx' >^2 \rangle}$$

$$< x^2 > = \frac{\sum_{i=1}^{N} \rho_i x_{i,c}^2}{\sum_{i=1}^{N} \rho_i}$$

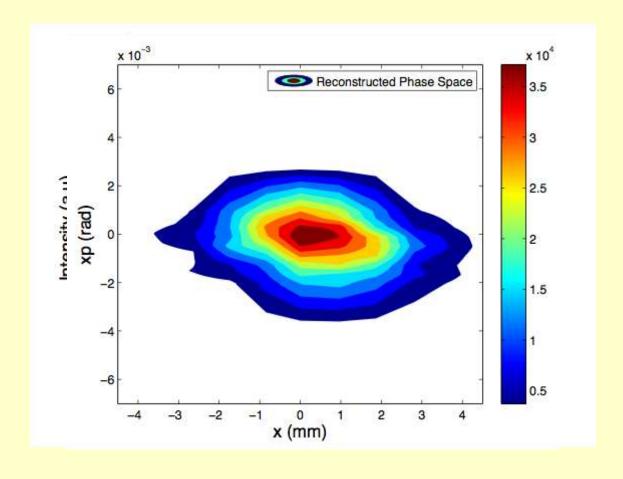
$$< x^{'2}> = \frac{\sum_{i=1}^{N} \rho_i (x_{i,c}^{'2} - \sigma_i^{'2})}{\sum_{i=1}^{N} \rho_i}$$

$$< xx'> = \frac{\sum_{i=1}^{N} \rho_i x_{i,c} x'_{i,c}}{\sum_{i=1}^{N} \rho_i}$$



Data analysis

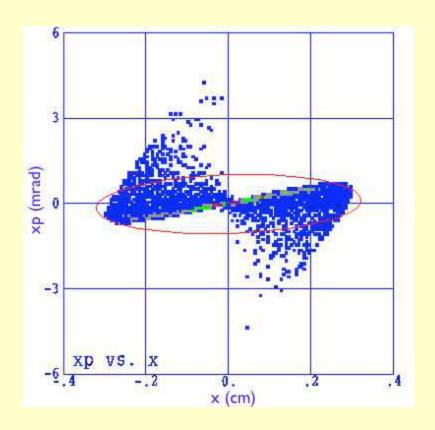


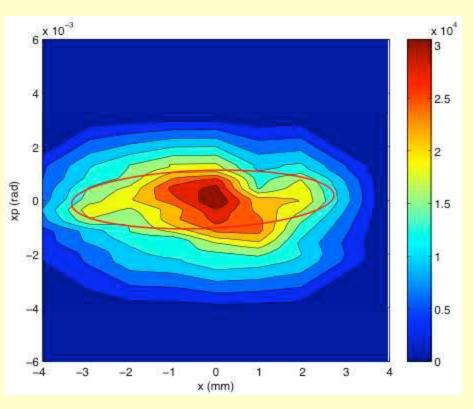




Example measurement vs simulation





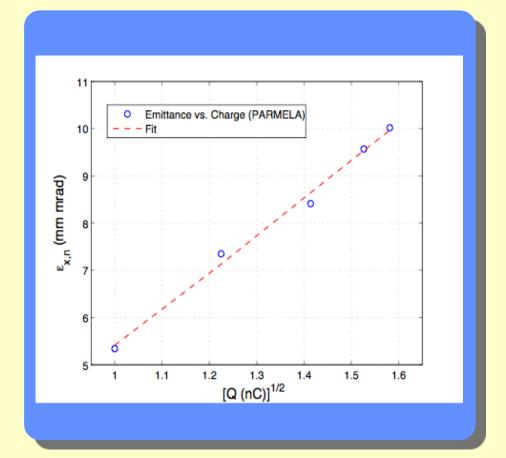


Example: ϵ = 10.7 mm mrad for 1.28 nC beam at the energy of 5.5 MeV. The measurement was performed with the laser spot size of 4 mm.



Emittance vs charge





$$\epsilon_n[mm\,mrad] \approx 1\mu m\sqrt{Q[nC]}$$

$$\epsilon_{n,x,y,tot} = \sqrt{\epsilon_{rf}^2 + \epsilon_{sc}^2 + \epsilon_{th}^2}$$

 ε_{rf} ~ 1.4 mm mrad ε_{th} < 1 mm mrad

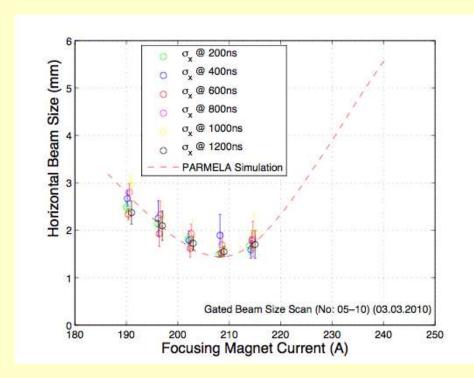
It is all about the space charge distribution

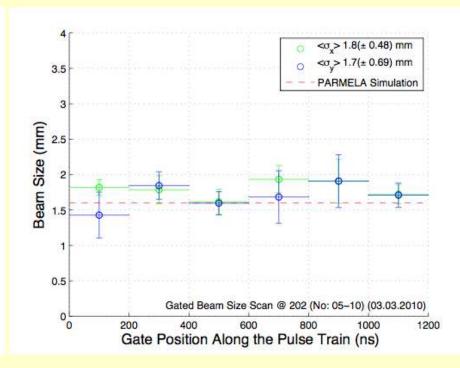
Can be optimized by laser shaping



Time resolved emittance measurements Beam size



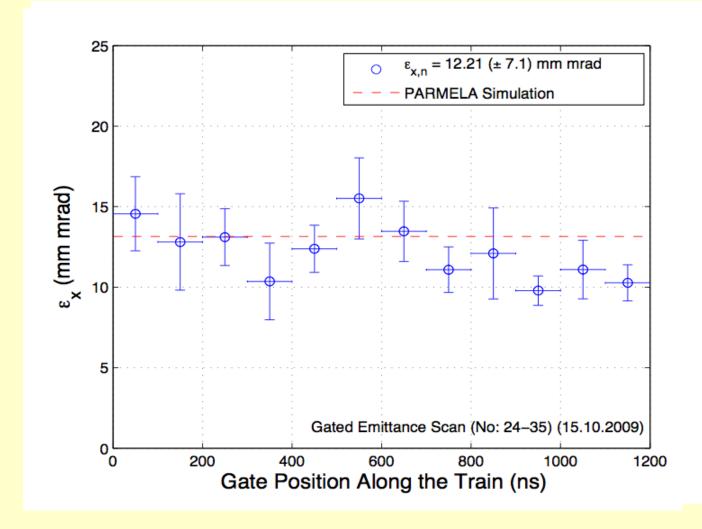






Time resolved emittance measurements

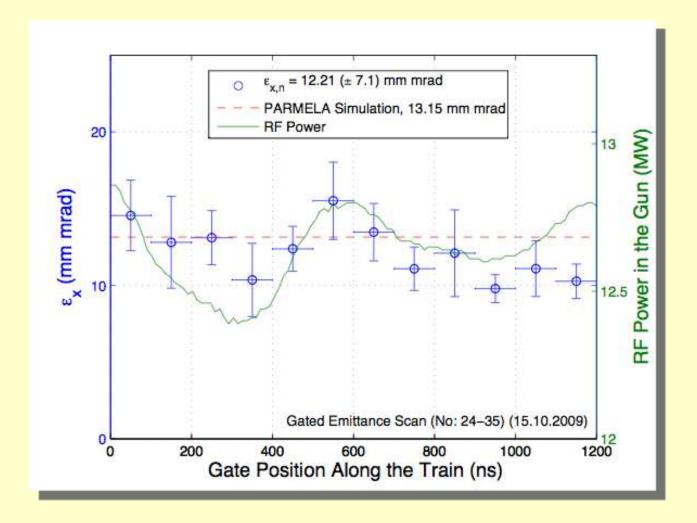






Correlation with rf power



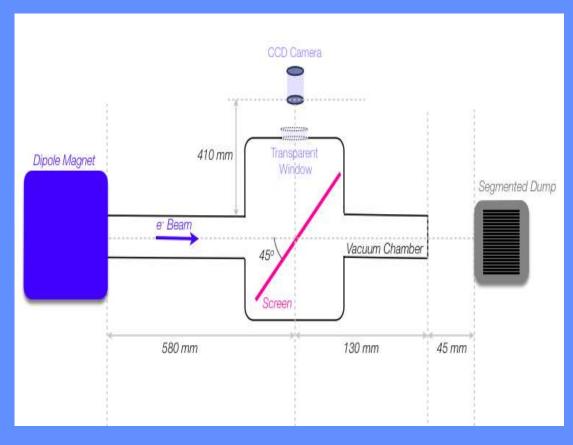




Spectrometer



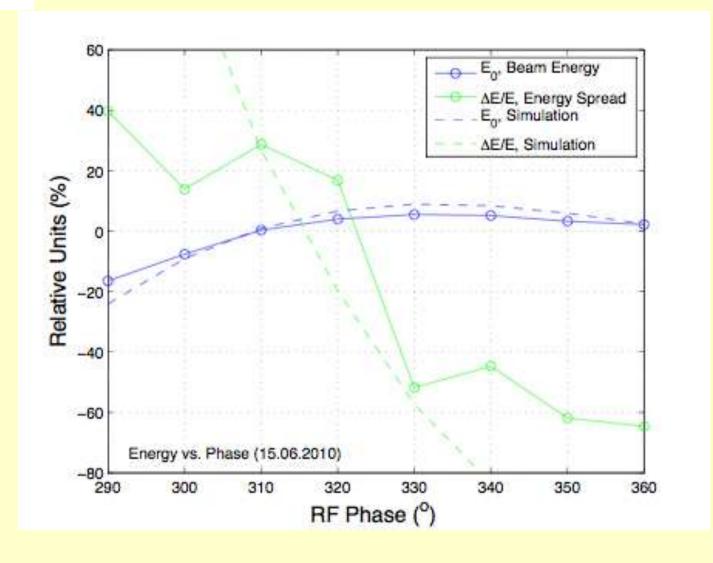
Spectrometer





Energy and energy spread

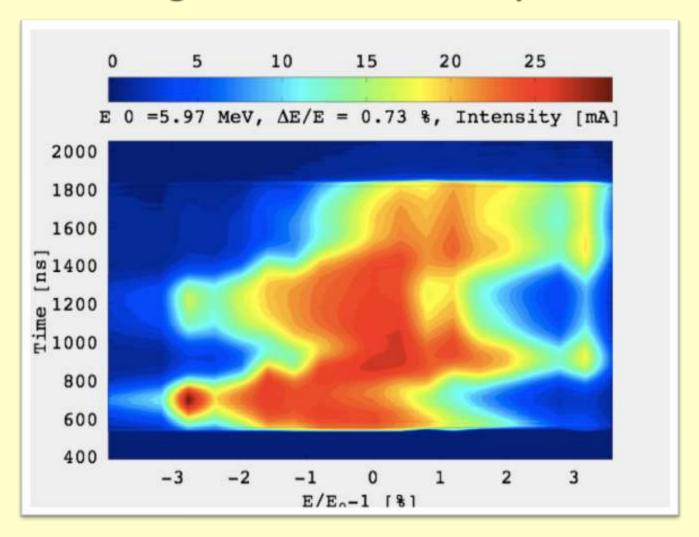






Time resolved energy spread segmented beam dump





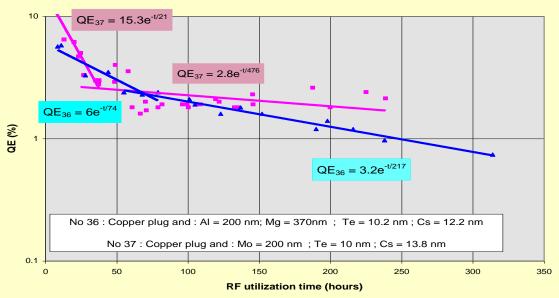


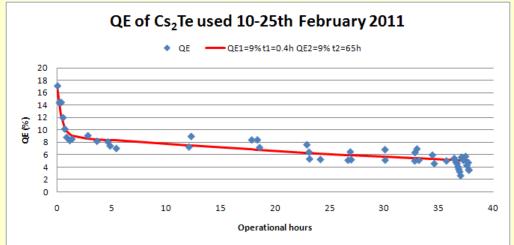
Cathode lifetime



Measurements from 1996 for Cs2Te

Lifetime of photocathodes No 36 and 37



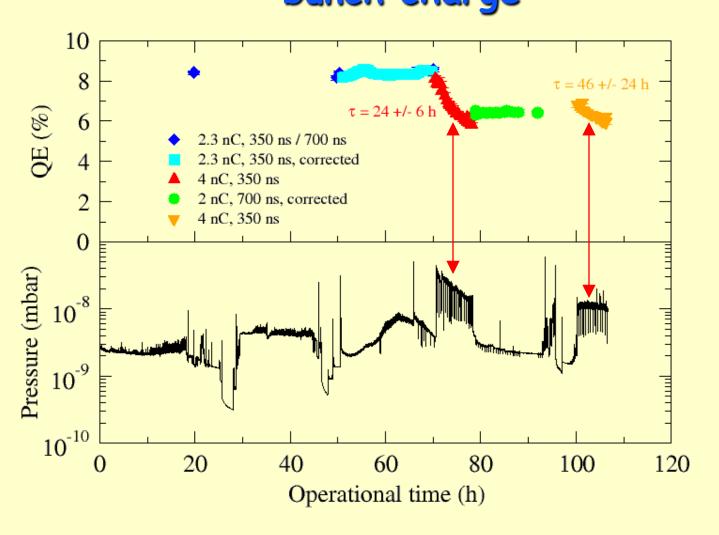


New software enables continuous Qe monitoring



Cathode life time studies Correlation with vacuum and bunch charge



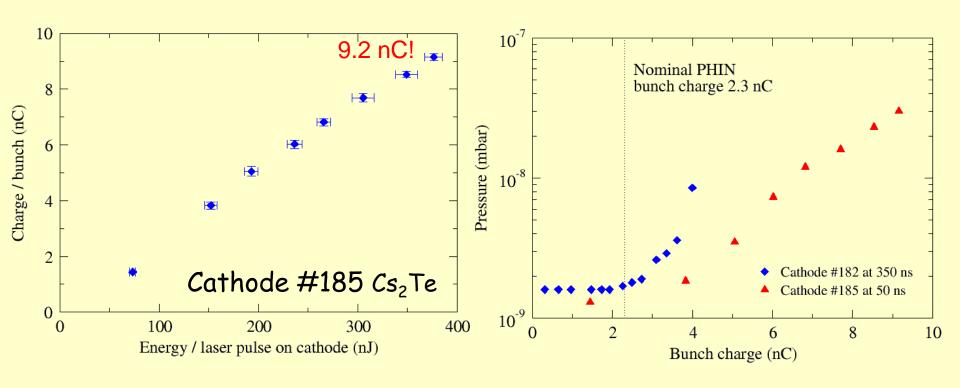




Cathode life time studies



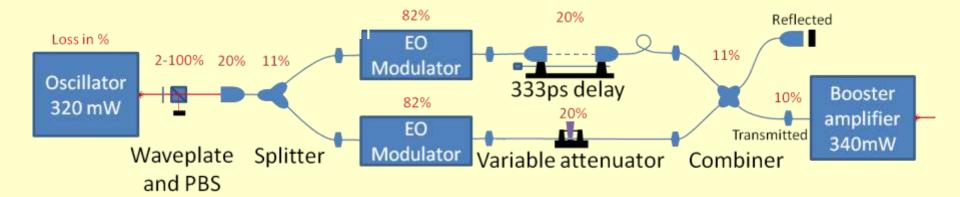
Again strong correlation with the pressure in the gun

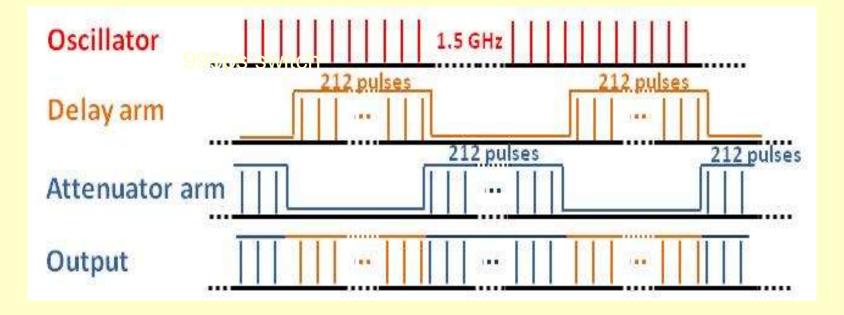




Phase coding



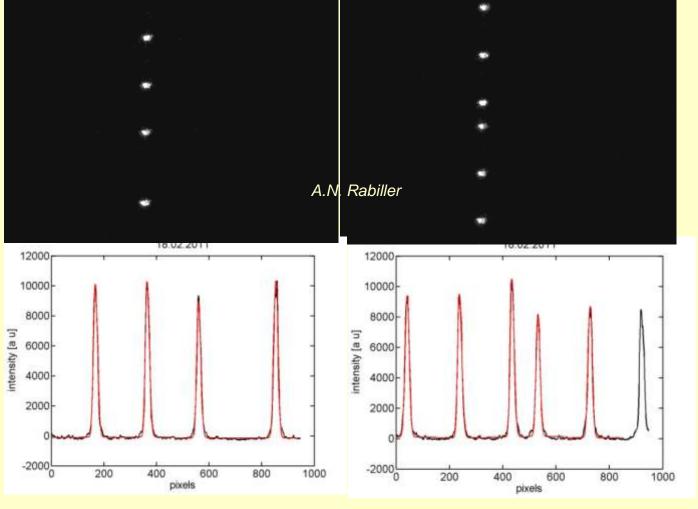






Streak measurements after AMP1&2





999ps switch

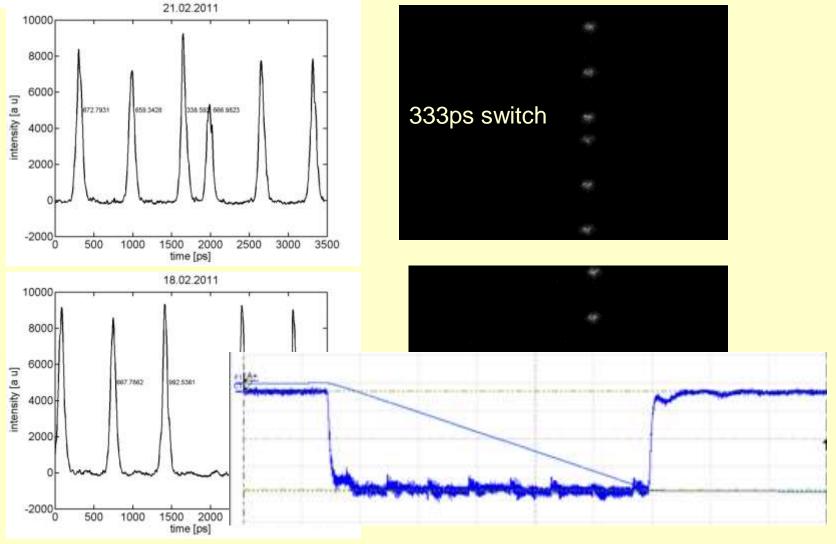
333ps switch

Using 523nm 2nd harmonic



Streak measurements with Cherenkov-line

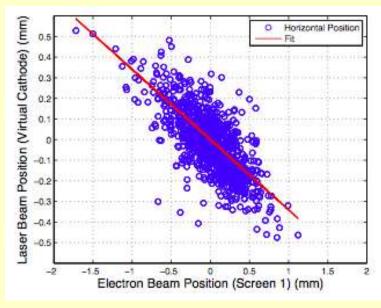


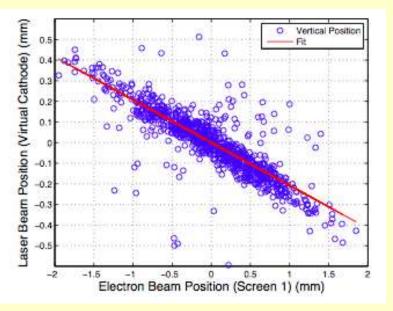


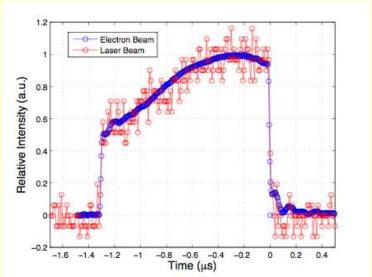


Correlation Between the Laser and the electron Beam











Stability



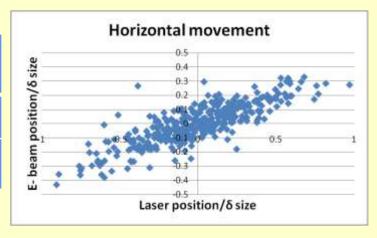
In laser room

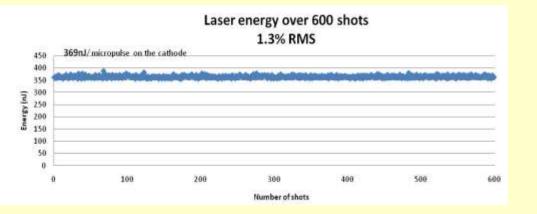
Macrop	IR	Green	UV
RMS stability	0.23%	0.8%	1.3%

Nonlinear conversion increases noise and causes amplitude variations along the train

In PHIN

Laser RMS	Current RMS	Train length(ns)	
1.3% RMS	0.8% RMS	1250	best
2.6%	2.4%	1300	worst

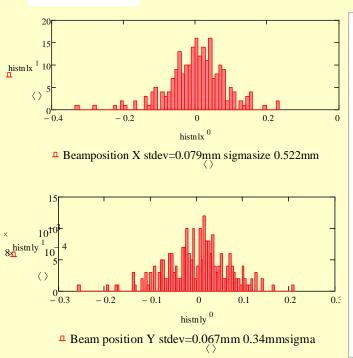


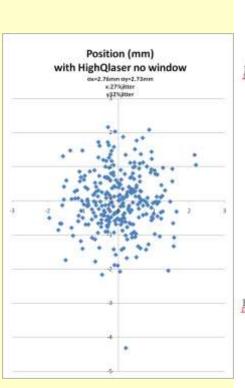


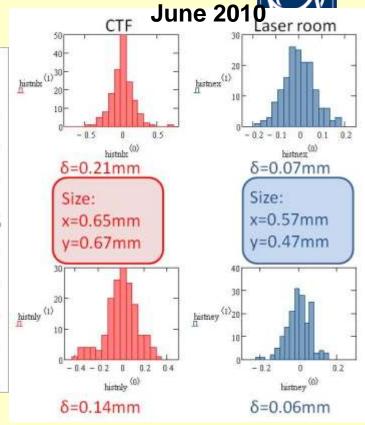
Beam stability seems almost entirely determined by laser stability First tests of feedback system is encouraging



Beam pointing stability







mm	June 2010 no cover	Feb 2011 HighQ input & cover	Feb 2011 fiber input &cover
Size x	0.65	2.76	0.344
δ movement	0.21 (32%)	0.74 (27%)	0.067 (19%)
Size y	0.67	2.73	0.524
δ movement	0.14 (21%)	0.87 (32%)	0.079 (15.2%)



Continuing research program Photo injector option



PHIN:

- study cathode lifetime:
 lifetime vs bunch charge (2-8 nC),
 total charge (0.5-4 μs pulse length),
 vacuum
- activate NEG chamber (partially done)
- test Cs₃Sb with green light (next run March 2012)
- study 8.4 nC beam dynamics, lower gradient?

CLIC DB beam:

Design 1 GHz rf gun and investigate if full pulse length can be demonstrated



CLIC DB injector specifications



Parameter	Nominal value	Unit
Beam Energy	50	MeV
Pulse Length	140.3 / 243.7	μs/ ns
Beam current	4.2	Α
Bunch charge	8.4	nC
Number of bunches	70128	
Total charge per pulse	590	μС
Bunch spacing	1.992	ns
Emittance at 50 MeV	100	mm mrad
Repetition rate	100	Hz
Energy spread at 50 Mev	1	% FWHM
Bunch length at 50 MeV	3	mm rms
Charge variation shot to shot	0.1	%
Charge flatness on flat top	0.1	%
Allowed satellite charge	< 7	%
Allowed switching time	5	ns



Challenges for the Photo injector option



- High single bunch charge 8.4 nC
- Extremely high total charge per pulse 590 μC
- Cathode life time, dynamic vacuum
- Extremely high average power for the laser
- Challenging stability requirements, laser, rf, ...
- Challenging 1 GHz rf system, 140 µs long pulse
- RF design and engineering for the rf gun, gradient and cooling
- Budget situation



Conclusions



- PHIN completely constructed and commissioned
- Experimental characterizations agrees with simulations
- Design parameters for CTF3 demonstrated including phase coding and high average charge
- Pretty good beam and laser stability, needs to be improved for CLIC
- Working towards a photo injector option for the CLIC DB injector